

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of:
Moon, et al

Serial No.: 10/025,144

Confirmation No.: 5051

Filed: December 18, 2001

**For: Method and Apparatus for
Polishing Metal and
Dielectric Substrates**

Group Art Unit: 2813

Examiner: Stephen W. Smoot

**Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450**

Dear Sir:

CERTIFICATE UNDER 37 CFR 1.10

I hereby certify that this correspondence and the documents referred to as attached therein are being deposited on 10/29, 2003, with the United States Postal Service in an envelope as "Express Mail Post Office to Addressee," mailing label No. EV335471025US addressed to: Mail Stop RCE, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Date _____

Signature

PRELIMINARY AMENDMENT

Prior to examining the above-referenced application, the Applicants request the application be amended as follows. **Amendments to the Claims** begin on page 2 of this paper. **Remarks** begin on page 10 of this paper.